

Docket No.: 239120US0DIV

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ATTORNEYS AT LAW

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/602,673

Applicants: Kazuhito MATSUKAWA

Filing Date: June 25, 2003

For: SEMICONDUCTOR SUBSTRATE,

SEMICONDUCTOR DEVICE, AND

MANUFACTURING METHOD THEREOF

Group Art Unit: 2826 Examiner: ERDEM, F.

SIR:

Attached hereto for filing are the following papers:

Request for Reconsideration

Our check in the amount of -0- is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

KAZUHITO MATSUKAWA : EXAMINER: ERDEM, F.

SERIAL NO: 10/602,673

FILED: JUNE 25, 2003 : GROUP ART UNIT: 2826

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REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

Responsive to the Office Action dated August 24, 2005, Applicant respectfully requests reconsideration of the above-identified application in view of the following amendment and remarks.

Remarks begin on page 2 of this paper.

Claims 1-4, 6, 8-12, and 17 remain pending in the application.